

<b>Notice of References Cited</b>	Application/Control No. 10/825,657		Applicant(s)/Patent Under Reexamination HATAKEYAMA ET AL.	
	Examiner Shean C. Wu		Art Unit 1756	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,045,257	05-2006	Hatakeyama et al.	430/7
*	B	US-5,686,980	11-1997	Hirayama et al.	349/110
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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